



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 10, 2026

IGI Report Number

LG816672453

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MARQUISE BRILLIANT

Measurements

14.15 X 6.64 X 4.08 MM

GRADING RESULTS

Carat Weight

2.10 CARATS

Color Grade

F

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

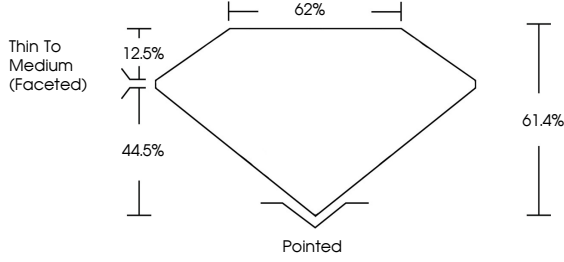
NONE

Inscription(s)

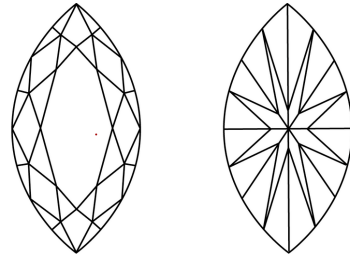
 LG816672453

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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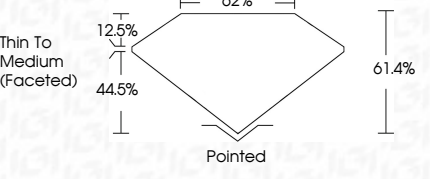
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July 10, 2026

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MARQUISE BRILLIANT

14.15 X 6.64 X 4.08 MM

2.10 CARATS

F

VVS 2

61.4%

62%

Thin To Medium (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

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